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EXPRESS MAIL NO. EL872041338US

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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Present Application:

Applicants : Michael Nuttall and
Garry Anthony Mercaldi

Attorney Docket No.: 500803.02

Filed : Concurrently herewith

Title : METHOD FOR ENHANCING VERTICAL GROWTH DURING THE
SELECTIVE FORMATION OF SILICON, AND STRUCTURES FORMED
USING SAME

Prior Application:

Examiner : David Vu

Art Unit : 2818

Serial No. : 09/770,909

PRELIMINARY AMENDMENT

Box Patent Application
Commissioner of Patents
Washington, D.C. 20231

Sir:

In the Specification:

Amend the specification by inserting a new section before the "Technical Field"
as follows:

-- CROSS-REFERENCE TO RELATED APPLICATION

This application is a divisional of pending United States Patent Application
No. 09/770,909, filed January 26, 2001. --

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